

First Named Inventor	Michael Smith
Serial No.	10/656,636
Filing Date	September 5, 2003
Group Art Unit	2811
Examiner Name	Unknown
Confirmation No.	8125
Attorney Docket No.	400.245US01
Title: TRENCH CORNER EFFECT BIDIRECTIONAL FLASH MEMORY CELL	

*Dfw*

**GENERAL  
TRANSMITTAL  
FORM UNDER 37 CFR 1.8  
(LARGE ENTITY)**

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**Enclosures**

The following documents are enclosed:

- Information Disclosure Statement (1 pg.); Form 1449 (7 pgs.); 58 copies of cited references; U.S. reference(s) not included pursuant to 37 C.F.R. 1.98 (c)(2)(i);
- An itemized return-receipt postcard

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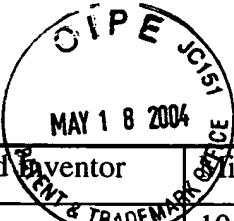
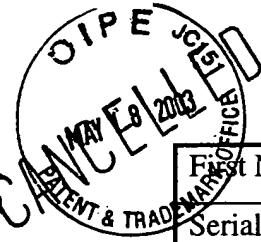
Name	Kenneth W. Bolvin	Reg. No.	34,125	Telephone	(612) 312-2211
Signature	<i>Kenneth W. Bolvin</i>			Date	<i>5/14/04</i>

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Name	Rhonda L. Foley	Signature	<i>Rhonda L. Foley</i>
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(LARGE ENTITY TRANSMITTAL UNDER 37 CFR § 1.8)



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In compliance with 37 C.F.R. §§ 1.56 and 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Pursuant to 37 C.F.R. 1.98 (a)(2)(ik), as this application was filed after June 30, 2003, Applicant has not included copies of U.S. Patents or U.S. Patent Applications. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

As an Office Action has not yet issued in this application, Applicant believes that no fees are due. However, the Commissioner for Patents is hereby authorized to charge any additional fees to Deposit Account No. 501373. If the Examiner has any questions or concerns regarding this application, please contact the undersigned at (612) 312-2211.

Respectfully submitted,

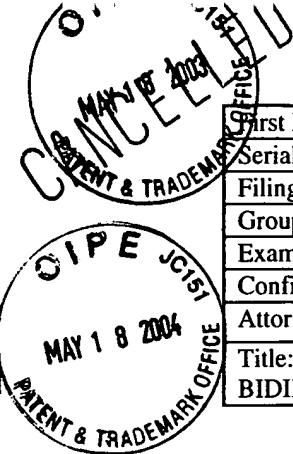
Date: 5/14/04

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## INFORMATION DISCLOSURE STATEMENT



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